



PATENT APPLICATION

IN THE U.S. PATENT AND TRADEMARK OFFICE

December 20, 2006

Applicants: Yoshio KAJIYA et al

For: METHOD OF PRODUCING CATHODE MATERIAL
FOR LITHIUM SECONDARY CELL

Serial No.: 10/521 370 Group: 1745

Confirmation No.: 2268

Filed: January 12, 2005 Examiner: Echelmeyer

International Application No.: PCT/JP2003/002027

International Filing Date: February 25, 2003

Atty. Docket No.: OPS 666

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

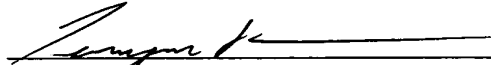
Sir:

In response to the Office Action dated August 24, 2006,
please amend the above-identified application as follows:

(Please see following pages.)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being
deposited with the United States Postal Service with
sufficient postage as first class mail in an envelope
addressed to: Commissioner for Patents, P.O. Box 1450,
Alexandria, VA 22313-1450, on December 20, 2006.


Terryence F. Chapman